

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Harry Hedler et al.

IAP20 Rec'd PCT/US 27 JAN 2006

Serial No.: Unknown

(Priority Application No. 103 34 577.9)  
(International Application No. PCT/DE2004/001360)Filed: Herewith  
(Priority Date 28 July 2003)  
(International Filing Date 28 June 2004)

Docket No.: I431.146.101/FIN 506 PCT/US

Title: **METHOD FOR APPLYING REWIRING TO A PANEL WHILE  
COMPENSATING FOR POSITION ERRORS OF SEMICONDUCTOR CHIPS IN  
COMPONENT POSITIONS OF THE PANEL****INFORMATION DISCLOSURE STATEMENT**Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement be entered and the documents listed on attached form 1449 be considered by the Examiner and made of record. Any required copies of patents, publications or other documents are enclosed for the Examiner's review. Pursuant to the provisions of M.P.E.P. 609, Applicants further request a copy of the 1449 form, marked as being considered and initialed by the Examiner, be returned with the next Official Communication.

Since this Information Disclosure Statement is being submitted within three months of filing national application; or date of entry of national application; or before the mailing date of the first Office Action on the merits, a fee has not been enclosed. However, if such fee is required, the Patent Office is hereby authorized to charge Deposit Account No. 500471 for fees as set forth under 37 C.F.R. 1.17(p).

10/566454

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**Information Disclosure Statement**

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Applicants respectfully request consideration of these references during prosecution of the above-identified matter. The Examiner is invited to contact the Applicants' representative at the below-listed telephone number if there are any questions regarding this Communication or the tendered references.

Respectfully submitted,

Harry Hedler et al.

By their attorneys,

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Dated: January 27, 2006  
SED:jan

Steven E. Dicke

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**CERTIFICATE UNDER 37 C.F.R. 1.10:**

"Express Mail" mailing label number: EV309843072US  
Date of Deposit: January 27, 2006

The undersigned hereby certifies that this paper or papers, as described herein, are being deposited in the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R. 1.10 on the date indicated above and is addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

By

Name: Vanessa Carels

<b>FORM PTO-1449</b>	Docket No.: I431.146.101/FIN 506 PCT	Serial No. Unknown Priority Appln. No. 103 34 577.9 Int'l Appln. No. PCT/DE2004/001360
<b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b>	Applicant: Harry Hedler et al.	
	Filing Date: Herewith Priority Date July 28, 2003 Int'l Filing Date June 28, 2004	Group Art: Unknown

## U.S. PATENT DOCUMENTS

## FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Sub Class	Translated Yes No
		0273703	07/1988	EPO			Yes
		0465138	01/1992	EPO			Yes
		10334577	07/2003	DE			Yes (Equivalent cited)
		19642488	10/1996	DE			Yes (Abstract Only)

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**


EXAMINER:

**DATE CONSIDERED:** \_\_\_\_\_

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.